

<b>Notice of References Cited</b>	Application/Control No. 10/022,143	Applicant(s)/Patent Under Reexamination PEIFFER ET AL.	
	Examiner Vivian Chen	Art Unit 1773	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-2003/0054129	03-2003	Peiffer et al.	428/97
	B	US-2003/0064195	03-2003	Peiffer et al.	428/141
	C	US-5,955,181	09-1999	Peiffer et al.	428/212
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N	DE 100 07 725 A1	08-2001	Germany	Murschall et al.	
	O	DE 100 07 723 A1	08-2001	Germany	Murschall et al.	
	P	DE 100 07 722 A1	08-2001	Germany	Murschall et al.	
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.